



PATENT
024703-006

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of :

SHIRO KAMIYAMA ET AL : ATTN: Application Branch

Serial No. 08/174,957 : Group Art Unit: 1101

Filed: December 28, 1993 :

For: METHOD FOR SURFACE :
TREATMENT OF ALUMINUM :
ALLOY HIGH-TEMPERATURE :
PROCESSED ARTICLES :

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

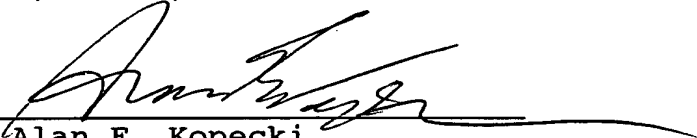
In accordance with the duty of disclosure as set forth in 37 CFR § 1.56, Applicants hereby make of record the Japanese Laid/Open Publication documents listed on the attached Information Disclosure Citation form (PTO-1449). Each of the listed documents is discussed in the specification of the subject application.

It is respectfully requested that acknowledgment of this filing be made concurrent with issue of an Official communication in the present application.

Respectfully submitted,

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By


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